

**SIEMENS**

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DO NOT ENTER: M.G.M.

05/24/2008

*6.19.08*

*RCE-2.17.08*

PATENT

Attorney Docket No. 2001P05854US02

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Inventor: Ralf Buergel, et al. ) Group Art Unit: 1792

Serial No.: 10/786,349 ) Examiner: Michael G. Miller

Filed: 02/25/2004 ) Confirmation No.: 4552

Title: METHOD FOR RESTORING THE MICROSTRUCTURE OF A TEXTURED  
ARTICLE AND FOR REFURBISHING A GAS TURBINE BLADE OR VANE

MAIL STOP AF  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 CFR 1.116**

Sir:

In response to the Final Office Action mailed March 18, 2008 Applicants respectfully submit the following amendment and remarks in connection with the above-identified application.

Entry of this paper is respectfully requested in order to overcome the rejections under 35 USC 112. Reconsideration of the rejections under 35 USC 102 and 103 are respectfully requested in view of the Remarks provided below.

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